

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s): Michael Puech

Appln. No.: 10/516,457

Conf. No.: 2874

Filed: December 3, 2004

Title: HEATING JACKET FOR PLASMA
ETCHING REACTOR, AND ETCHING
METHOD USING SAME

PATENT APPLICATION

Art Unit: 1792

Examiner: Jeffrie R. Lund

Customer No. 23910

REPLY AND AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Reply and Amendment is in response to the Office Action dated May 6, 2009.

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.